

Experience with (resistive) Micromegas for sampling calorimetry

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Outline

- Introduction
 - Particle Flow calorimetry
 - Micromegas as sensitive medium
- Non-resistive Micromegas
 - Possible mechanical designs
 - Readout options for EM showers
 - Readout options for Hadron showers
 - Some performance of large-area prototypes
 - Magnetic field & spiralling delta-electrons
- Resistive Micromegas
 - A simple model including time constants
 - R-electrodes shapes and resistivity
 - Sparks VS linearity, test protocols & results

Particle Flow calorimetry

Particle Flow (imaging) calorimetry for future LC (or at LHC & HL-LHC)

Introduced to improve the energy resolution on jets (calorimeters inside the coil):

Granularity + software → match tracks & showers → use calorimeters only for neutrals

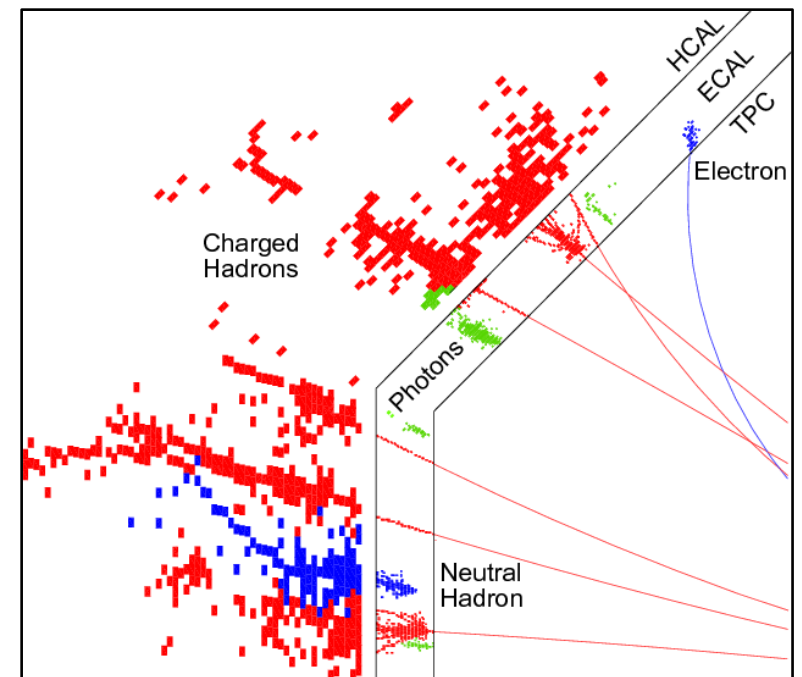
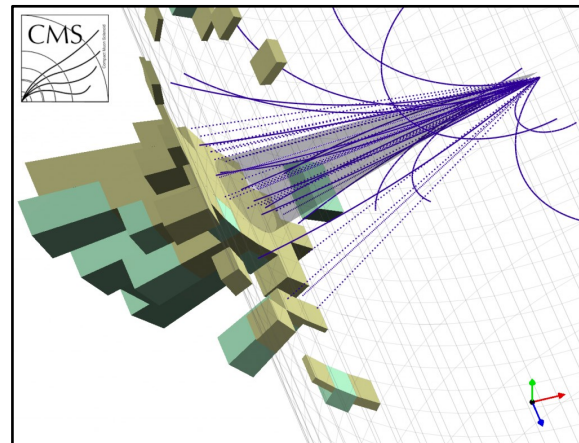
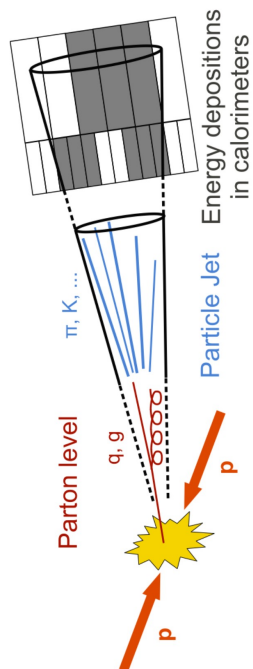
Works till jet cone too narrow → minimise confusion with small cells & compact showers

General requirements on sensitive medium (e.g. Si, Sc, Gas)

Small Moliere radius, large-area & thin sensors, high sampling fraction

[LC: + other technical requirements (front-end electronics on PCB, power-pulsing, self-trigger)]

... gas detectors apparently not favoured



Sampling with MPDG/Micromegas

Still, (Micro Pattern) gas detectors present several advantages

Cheap (argon), proportional mode, large area, fine segmentation, no ageing, no rate dependence

Micromegas, 3 mm drift gap, 1x1 cm² pads

MIP ~ 0.3 keV (15 e⁻ MPV), Moliere radius already high (4.5 cm) but fine for HCAL

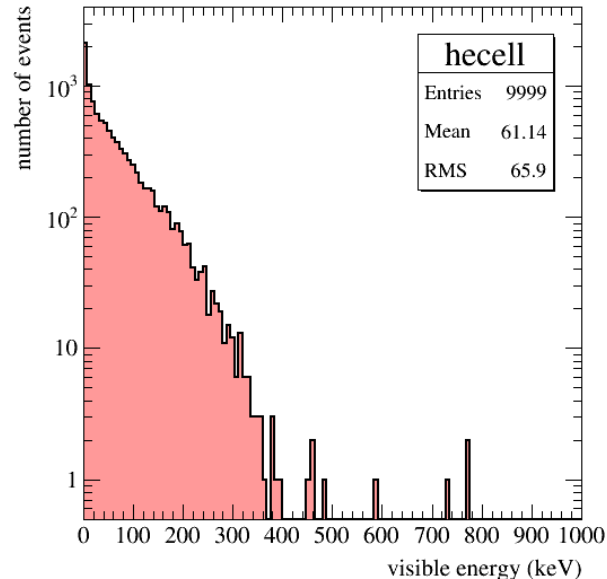
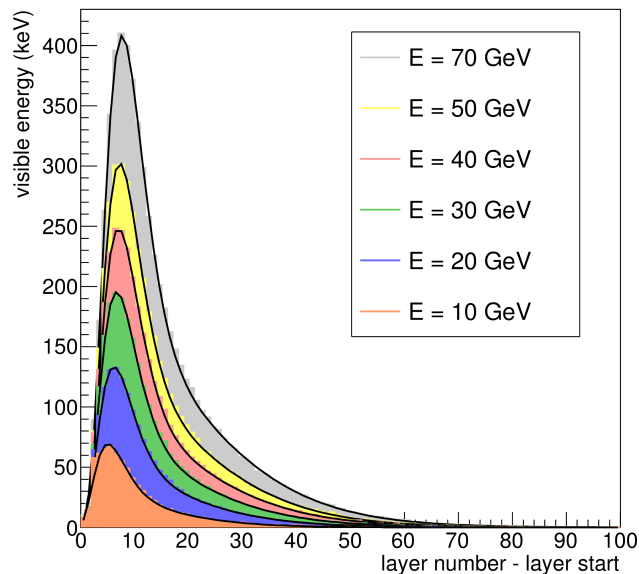
HCAL (1.5 cm Fe absorbers), 50 GeV pion shower (Geant4)

@ shower max.: 300 keV / layer, 60 keV in central pad with fluctuations up to 300 keV

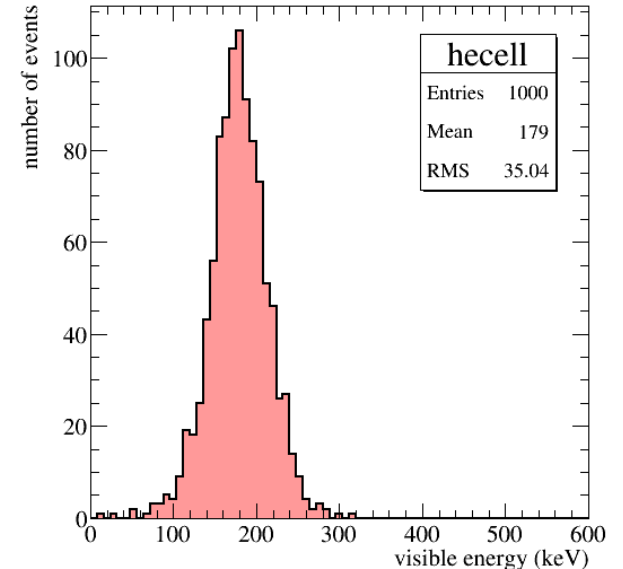
In usual Ar-CO₂ mix.: all electrons arrive at the mesh in < 75 ns

ECAL (2.5 mm W absorbers), 50 GeV electron shower (Geant4): 180 keV in central pad

HCAL - Energy Profile and energy in central pad @ shower maximum



ECAL - Central pad energy



Possible mechanical designs

Target area for LC/SiD HCAL is 3000 m², layer of 3x1 m² to fit in 1.2 cm absorber gaps

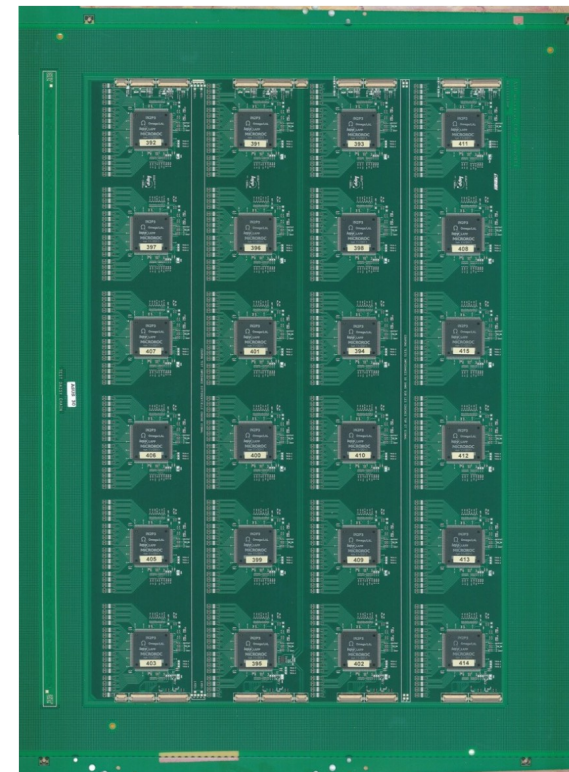
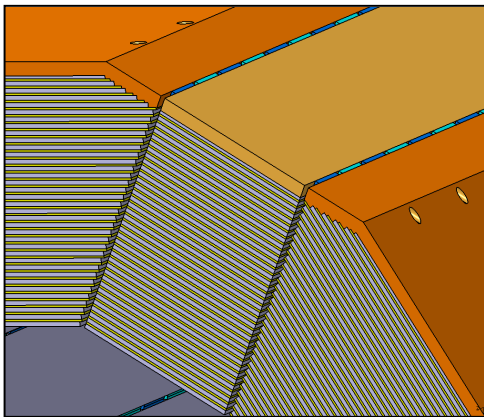
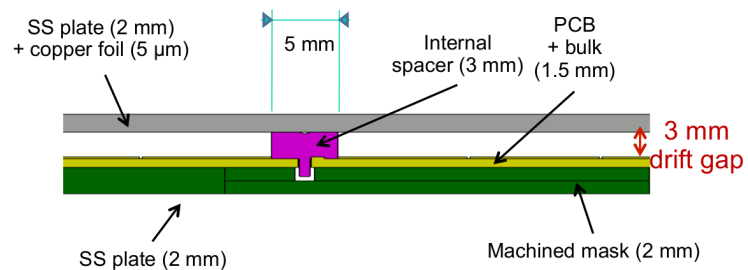
→ Bulk (better suited than InGrid), implies lamination of photo-films+mesh on PCB
Size limitations from PCB manufacturer, Cabling of ASICs, Rui's workshop

*Back In 2011, we choose 1x1 m² ~ (32x48 cm²) * 6*

→ spacers between PCBs (dead zones ~ 2%), we are currently working on 48x48 cm² units.

Design strongly constrains by thickness requirements of ~ 1 cm

→ No screws, everything is glued (sealed, “no way back”)



Readout options for EM showers

No space available for active cooling inside LC calorimeters

→ power-pulsing + low-power electronics (save on analogue part)

ECAL should measure showers and MIP tracks

→ large dynamic range (0.1-1000 MIPs) & high ADC resolution (e.g. 16-bits)

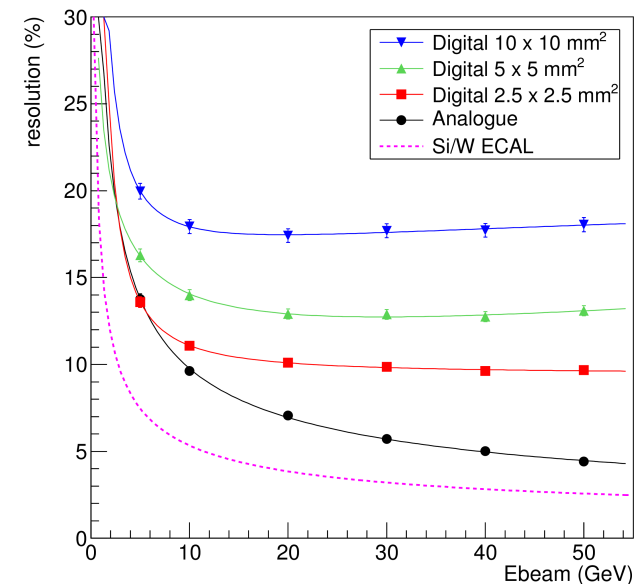
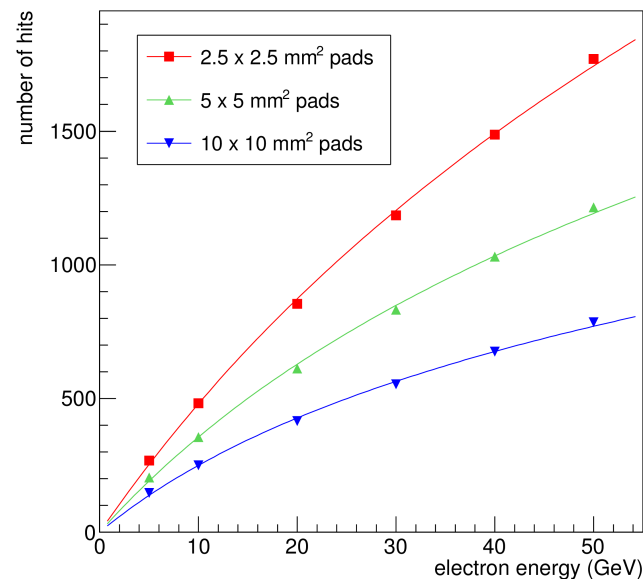
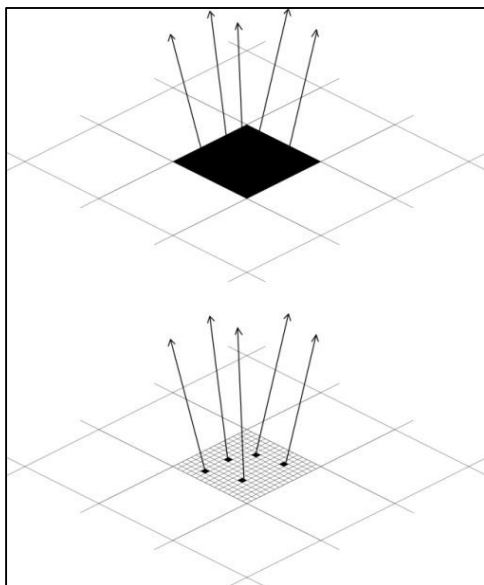
Digital option (16-bit → 1-bit) works if $N_{particle} / cell < 1$

This depends on relative size of shower cone & cell

For ECAL = use pixels or stick to analogue readout (in which case, intrinsic detector linearity is a must)

For HCAL, might be good enough...

ECAL W-Ar: Digital response (1x1 cm² pads) – Energy resolution



Readout options for H showers

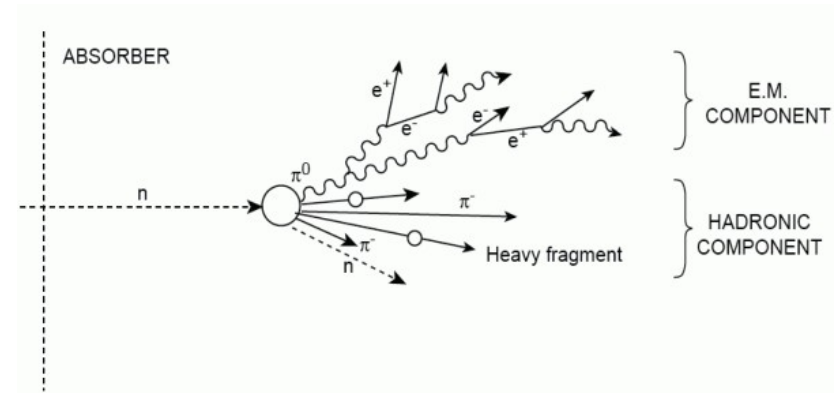
Digital option: shower transverse size VS cell size

H shower = EM part (from π^0 , η) + H part (n, π , p...)

EM fraction increases with H energy

→ Digital might work at “low” energy

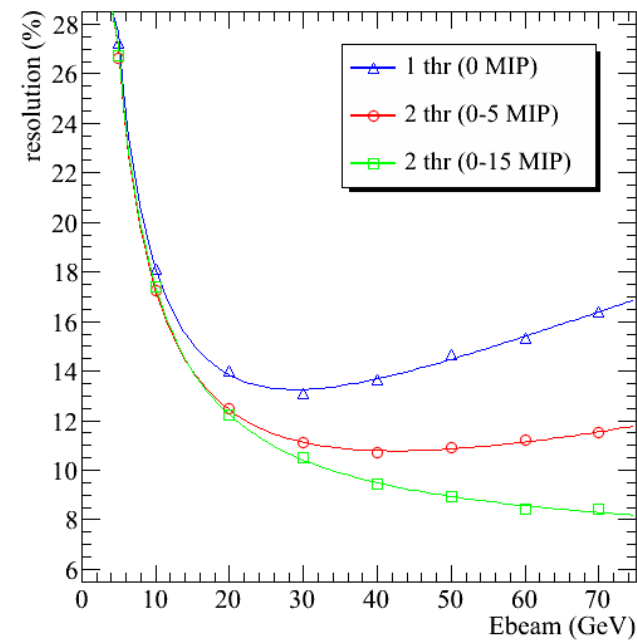
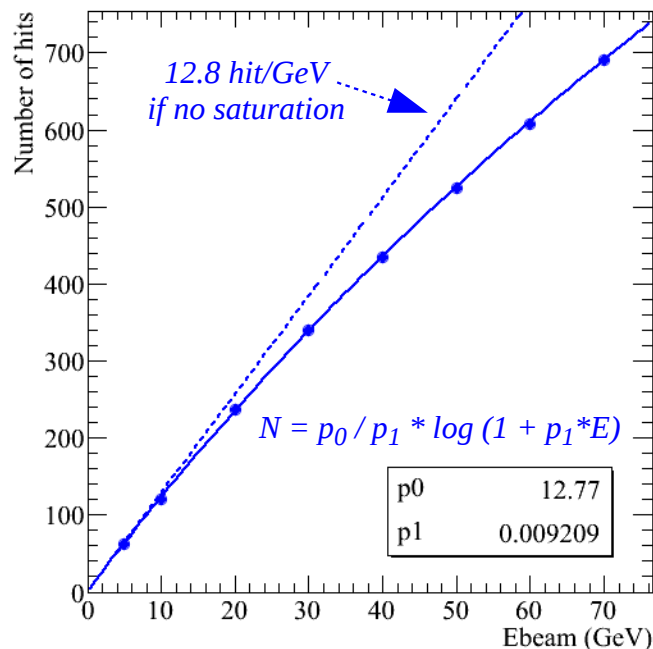
Absorber choice is important ($R_M(W) < R_M(Fe)$)



Semi-digital option (1-bit → 2-bit) to compensate geometrical saturation

Relies on intrinsic detector linearity, favours MPGD VS saturated devices (e.g. RPCs)

Response and resolution to single pions of a $11 \lambda_{int}$ deep **Fe/Ar DHCAL** with $1 \times 1 \text{ cm}^2$ cells



1x1 m² prototype performance

Already reported in RD51, *this is just a reminder of important results*

Combined test with RPC (CALICE SDHCAL SPS/H2)

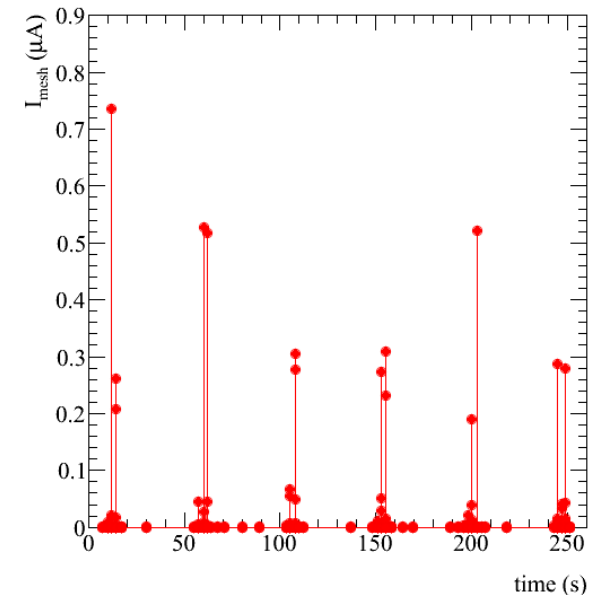
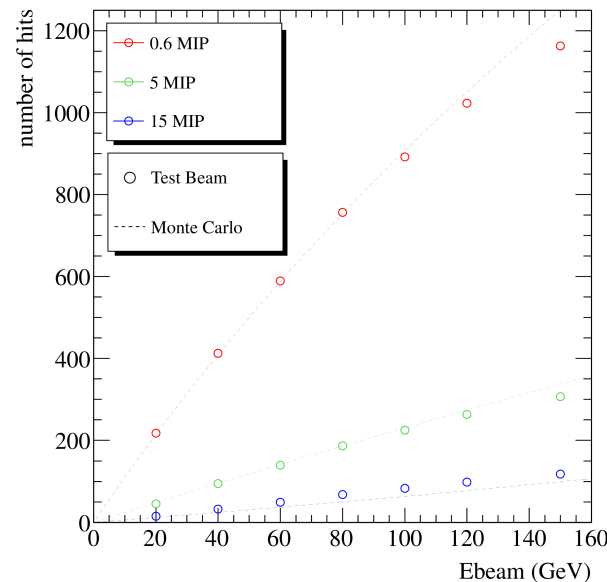
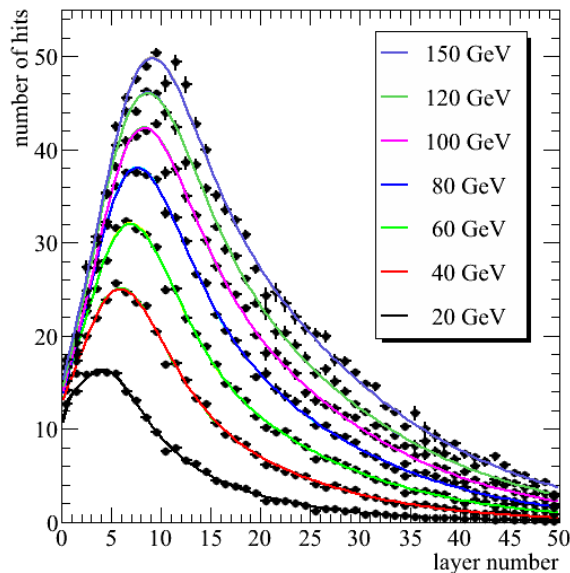
The expected geometrical saturation is observed (deduced from longitudinal profiles)

Standalone test (SPS/H4), findings should hold for any MPGD

Excellent uniformity (eff. 95%, abs. variation of 1% RMS)

No effect of rate on response (verified up to 30 kHz pion showers, beam of 1x1 cm²)

Except during **occasional sparks** (10^{-5} / shower, EM core fluctuations, nuclear recoils)



Magnetic field & spiralling electrons

Colliding beam experiment with Barrel, 2 Endcaps [Calorimeters inside solenoid]

Endcap: No ExB effects, drift velocity unchanged

Transverse diff. reduces with $\omega\tau$, Rather limit possibly closer

Barrel: more problematic, high-energy delta-electrons

Lorentz force + initial momentum \rightarrow travel over a few cm!

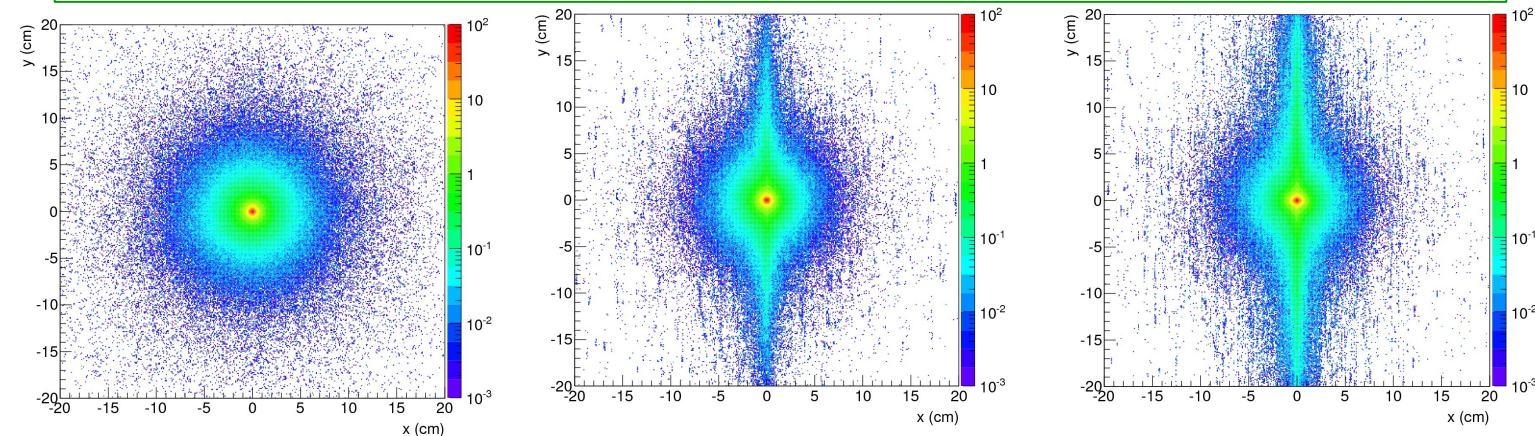
Was simulated for an ECAL geometry (2.5mm W + 2.5 mm Ar)

Small effect on EM shower shape (log-scale below!) but large on measured energy & resolution

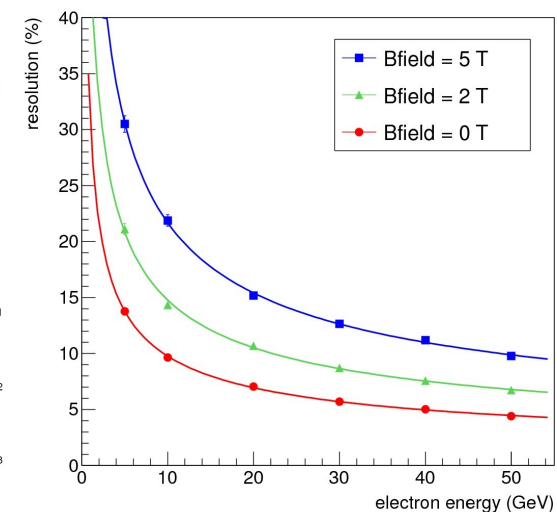
For hadron shower, impact should be less (high track density in EM core only), to be simulated (can be identified and removed?)



ECAL W-Ar: 50 GeV electron showers with no B field and in 2 T and 5 T field



Energy resolution to electrons in magnetic field



Sampling with Resistive Micromegas

Guarantee stability in showers by suppressing sparks

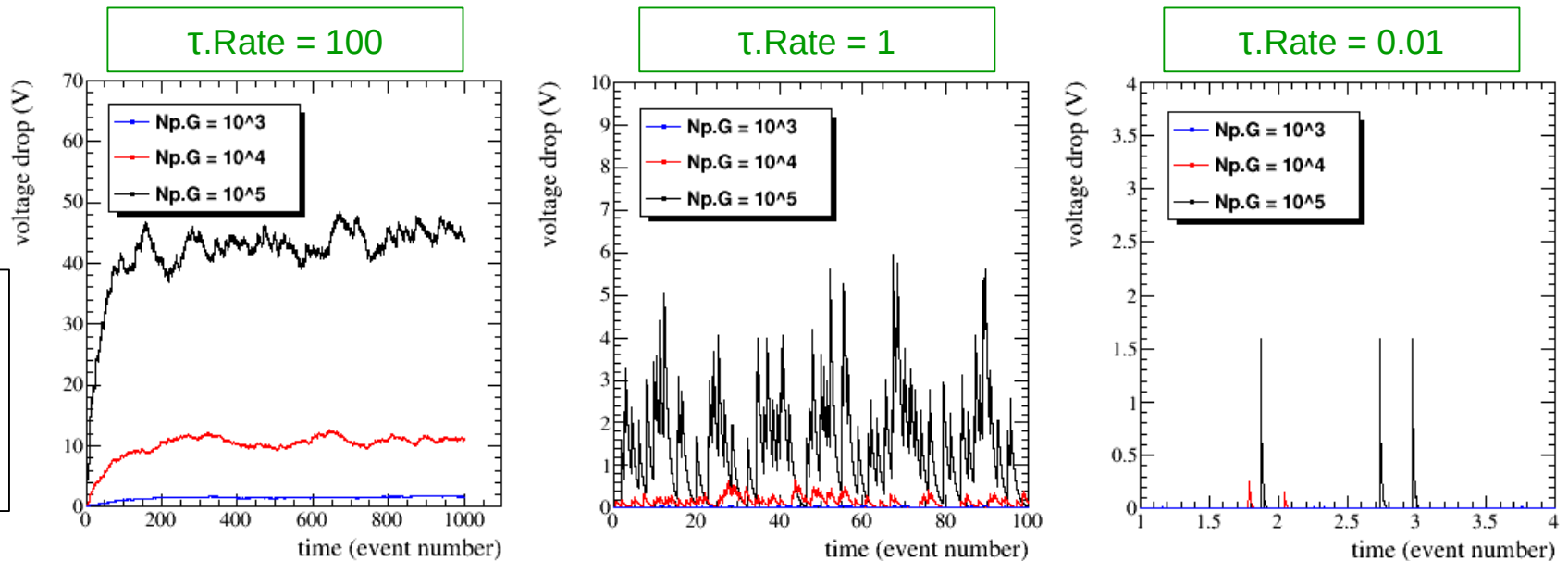
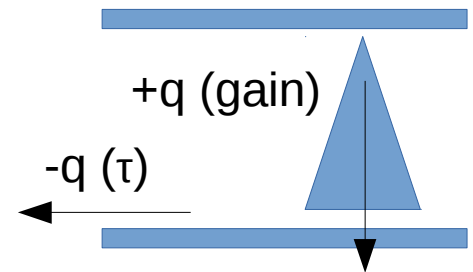
The RC network implies that the charge stays on the R-electrode for a while, changing locally the voltage: above some charge the field reduces significantly, avoiding sparks.

But might comprise the intrinsic linearity of MPGD, depending on the scenario

Time-dependent charge-up effects, the simplest model: all electrons arrive at the same time

- * Effective capacitance (transverse size of the avalanche), relates dQ to dV , 1 pF for $R = 2 \cdot \sigma$ (σ of 325 μm)
- * RC constant (geometrical capacitance)
- * Gain (G_0 , voltage dependence)
- * Beam (flux, number of primary e^- N_p)
- * Gas (transverse diffusion Dt)

$\tau \gg 1/\text{Rate}$, fluctuations around mean value reached after $\tau = RC$
 $\tau \sim 1/\text{Rate}$, continuous charge-up with positive fluctuations above 0 V
 $\tau \ll 1/\text{Rate}$, charge-up during event if total charge high enough
 → linearity degradation at low rate



$\tau.Rate=100$
Gain drop
 70%
 25%
 5%

Resistive electrode shapes

Different ways to introduce RC

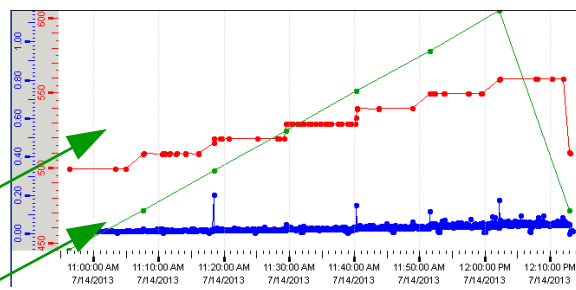
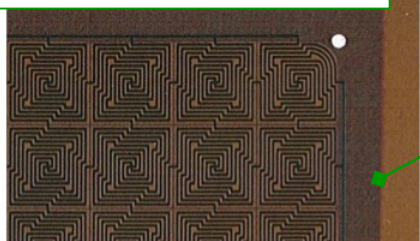
2012-2014 (ANR-funded project: Spark Protected Large Area Micromegas)

→ Spark suppression demonstrated (DESY) @ the cost of rate capability loss

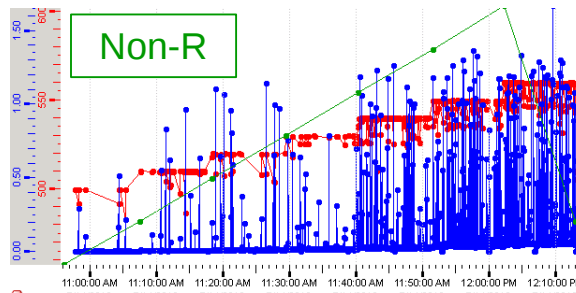
Small prototypes (with embedded digital front-end electronics)

0. Continuous horizontal R grounded on the side forbidden (would increase pad-to-pad cross-talk)
1. **Horizontal R layer (grounded on PCB side)** with meanders to reduce X-talk
2. **Horizontal pad-segmented R** to avoid X-talk **with through-PCB via** for grounding
3. Vertical R, so-called **embedded resistance contacting R and readout pads** (did not work because of fabrication errors, much progress since then...)

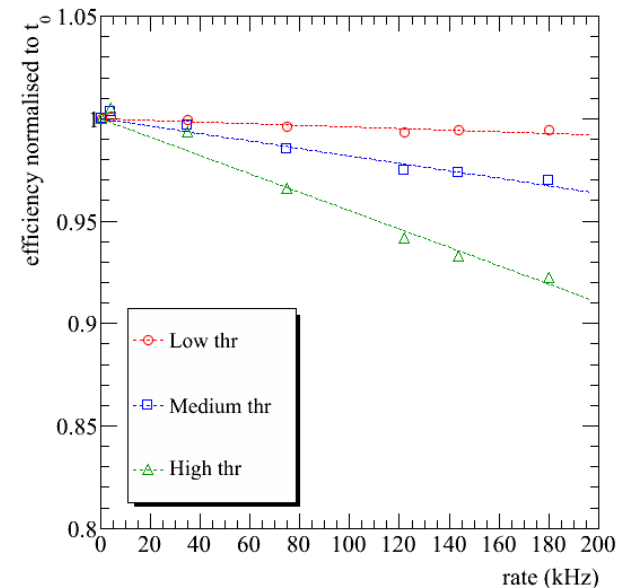
1. Rlayer + meanders



2. Rpad + PCB-via



Efficiency loss VS ebeam rate



Electrode resistivity

Resistive electrode shape

Horizontal R not suited for large-area (R linearly adds up), through-PCB via not cost effective
Vertical R fully scalable → stick to embedded R and minimise rate effects, i.e. minimise RC

What is the minimal resistivity needed to suppress sparking?

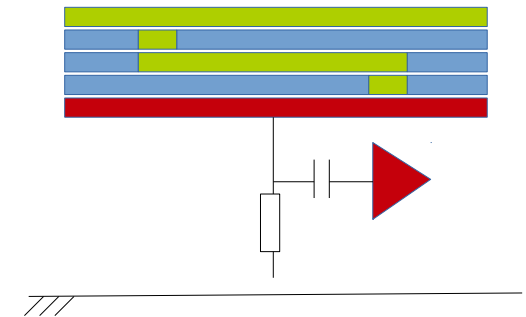
Empirical approach:

Prototypes with resistivity varying over several orders of magnitude

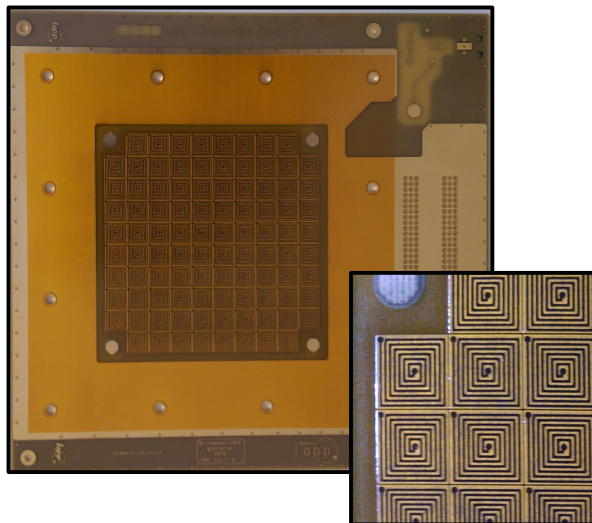
SCREAM (Sampling Calorimetry with Resistive Anode Micromegas
→ Demokritos (T. Geralsis), CEA/Irfu (M. Titov), IN2P3/LAPP

What is the effect of RC on signal magnitude?

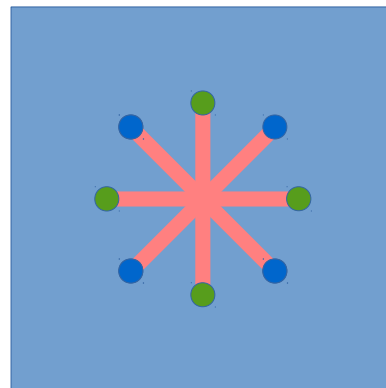
Buried resistor



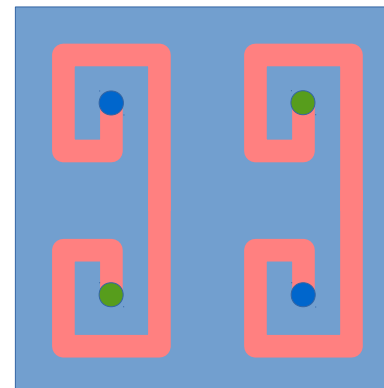
Board for Gassiplex RO



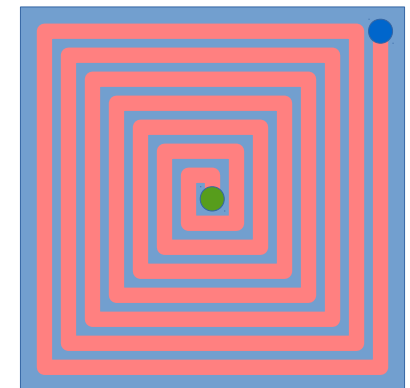
Star, 400 k Ω , $\tau = 40 \mu\text{s}$



Mirror, 4 M Ω , $\tau = 0.4 \text{ ms}$



Snake, 40 M Ω , $\tau = 4 \text{ ms}$



Green dot = R-pad contact, blue dot = RO-pad contact

Experimental protocols

What is the effect of RC on signal magnitude?

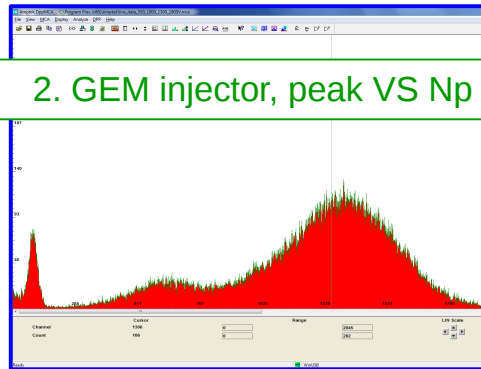
→ Measure influence of detector current (rate & dE/dx) on gas gain

1. High rate ($\tau \gg 1/\text{Rate}$) Rate scan @ constant dE/dx : X-gun
2. Low rate ($\tau \ll 1/\text{Rate}$) dE/dx scan @ constant rate: GEM-injector
3. Medium Rate ($\tau \sim 1/\text{Rate}$) Rate scan @ variable dE/dx : pion beam (showers)

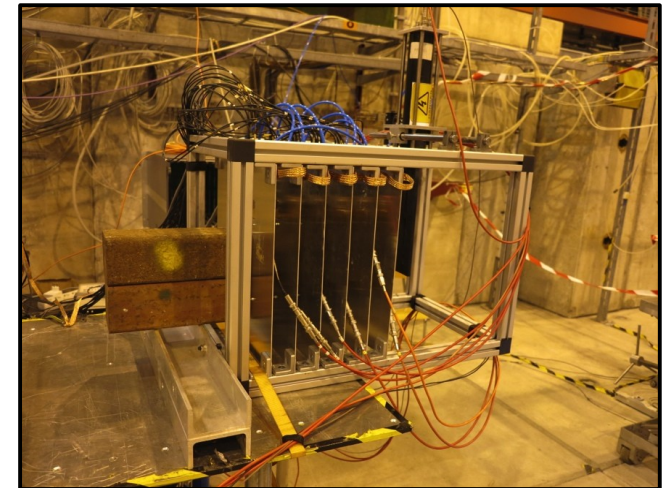
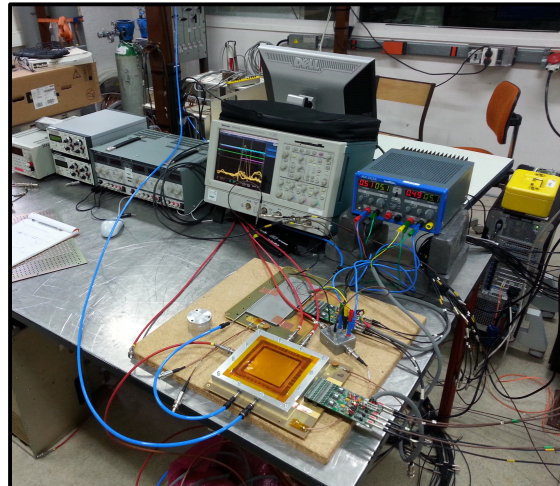
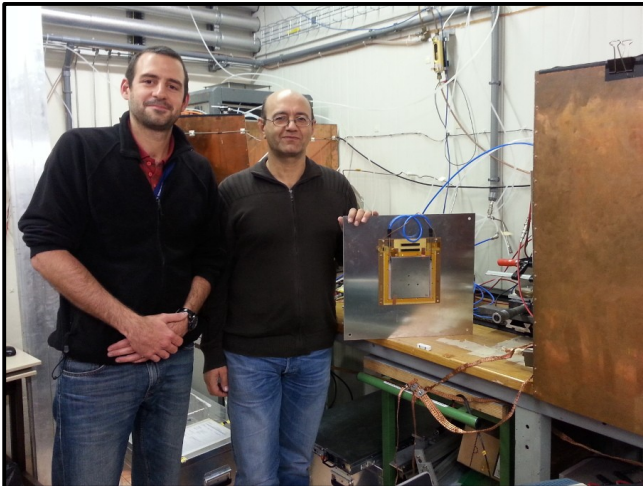
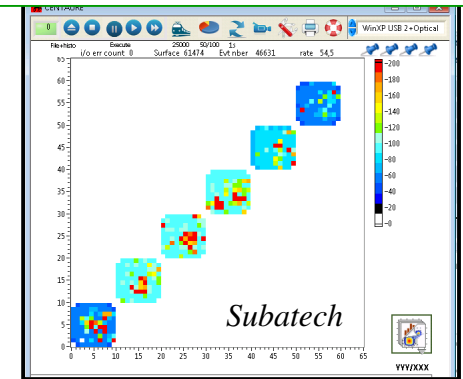
1. X-gun, I mesh VS rate



2. GEM injector, peak VS Np



3. Beam, ADC sum VS Rate



High rates

Detector time constant >> event rate

Influence of one event on next one? Yes, of course.

Setup 1: 8 keV X-rays, Rate [10,100] MHz → measurable current on HV-supply, gas gain up to 10^3

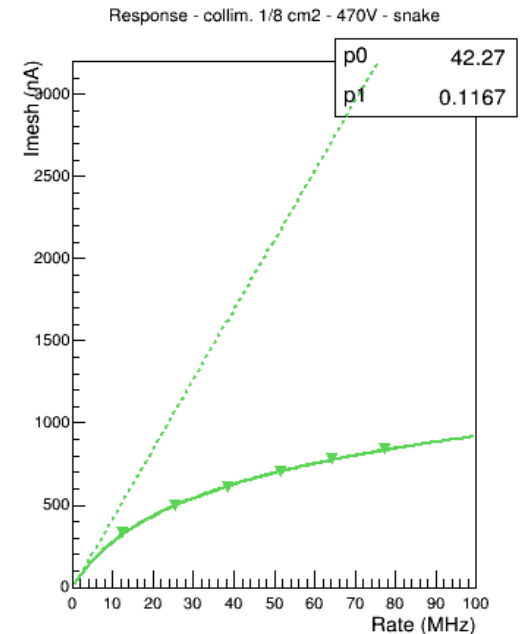
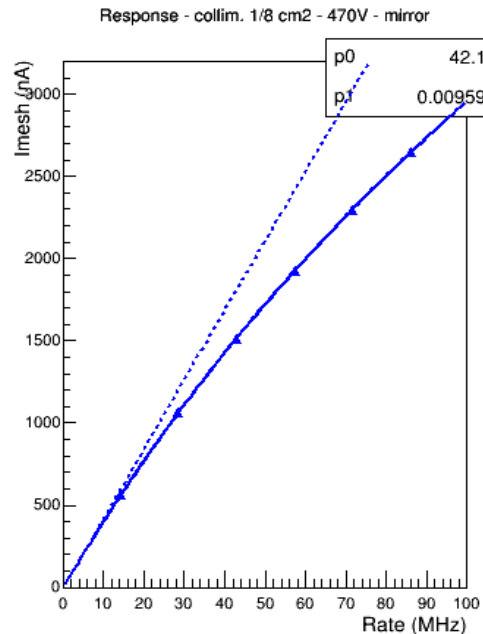
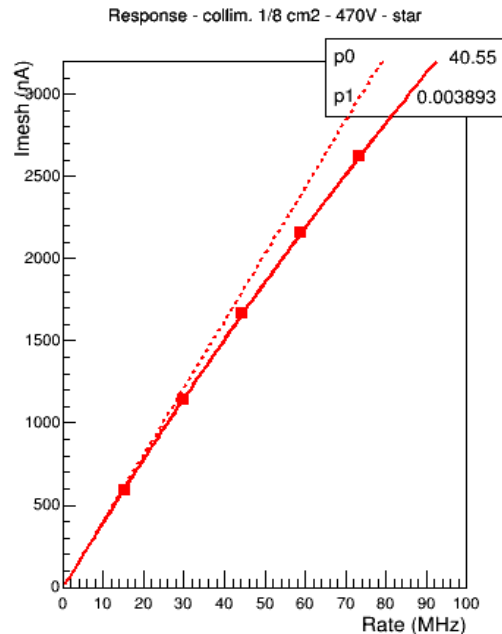
At given rate, gain drops and quickly stabilises (evacuated Q ~ incoming Q on R pad)
Departure from linear response calculated from log-fit.

Extrapolation @ 1 MHz yields deviations of ~0.5%, 1%, 10% (Star, Mirror, Snake).

Star, 400 kΩ, $\tau = 40 \mu\text{s}$

Mirror, 4 MΩ, $\tau = 0.4 \text{ ms}$

Snake, 40 MΩ, $\tau = 4 \text{ ms}$



Low rates

Detector time constant \ll event rate

Influence of first primary electrons space charge on last primary e- multiplication? Not sure...

Setup 2: GEM injector (Geff up to 800) + low activity ^{55}Fe source (100 Hz event rate) + Pocket MCA
After diffusion, primary electrons arrive at the mesh within ± 65 ns, distributed with ± 325 μm
Bulk gain from 10^2 to 10^4

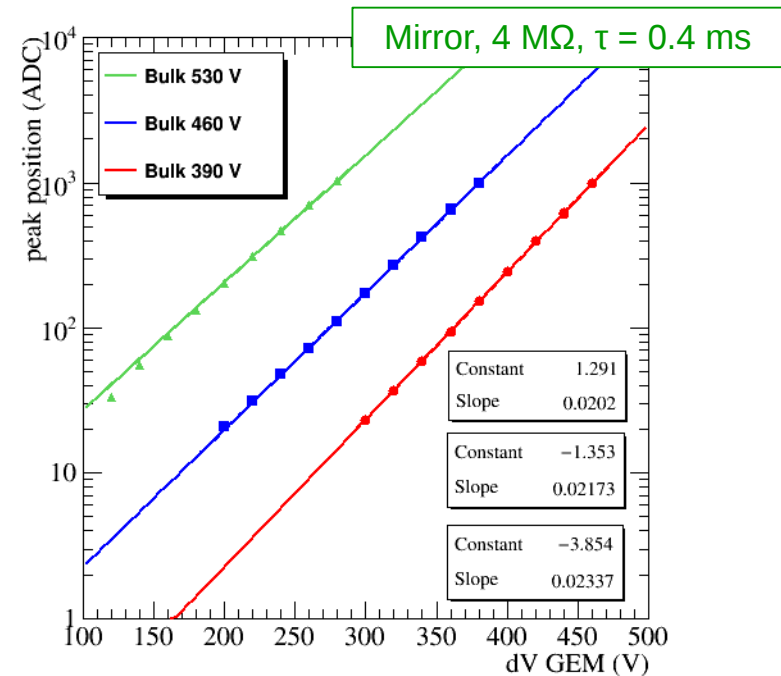
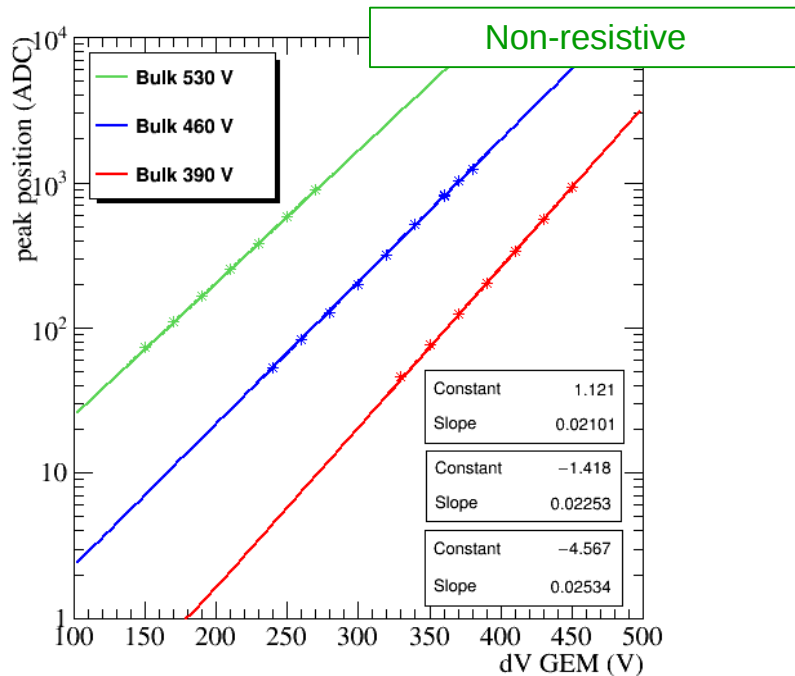
Ability of R pad to charge-up given by its capacitance only (RC does not matter here)

$C_{\text{eff}} \sim S$ with S the spread of the Q distribution onto the pad (~ 1 pF)

Saturation of readout at overall gain (Bulk*GEM) of 10^5 , pity, GEM & Bulk could go higher.

Comparing response curves (photopeak VS V_{gem}) in R and non-R prototypes:

Slopes slightly lower for R-prototypes, any effect? More test needed, probably at higher gains.



Intermediate rates

Intermediate rates: Detector time constant ~ event rate

Events influence each other if dE/dx high enough

Setup 3: Rate scan in test-beam (pion with or w.o. absorber (2 int. length of iron))

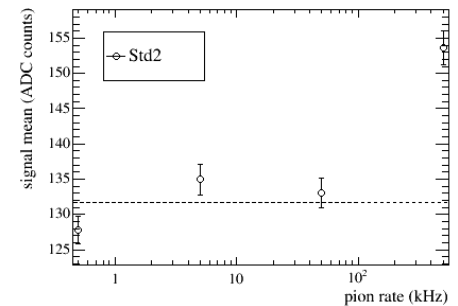
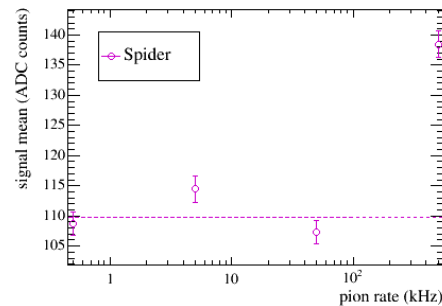
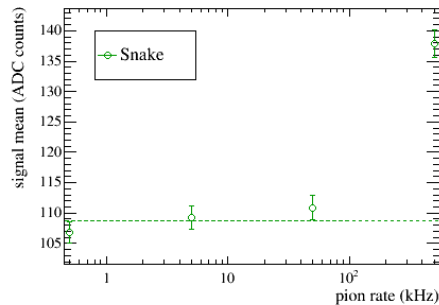
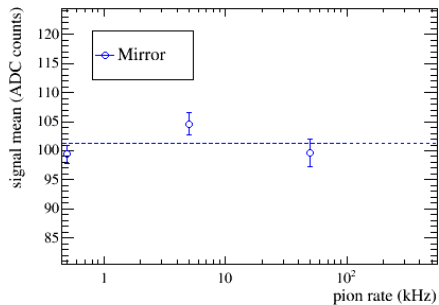
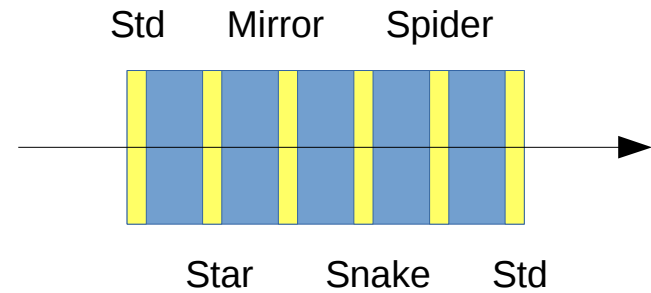
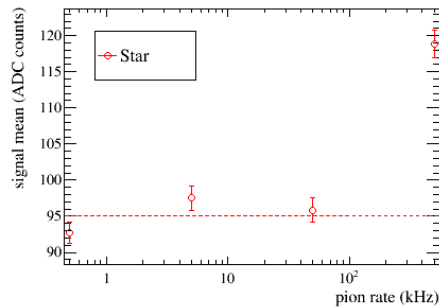
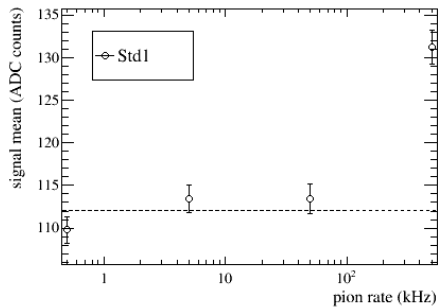
Runs @ beam intensity of: 0.5, 5, 50, 500 kHz/cm²

Shaping time of Gassiplex chips (1 us) → last point only useful for sparking study

No absorber → MIPs yield small charge, average measured charge constant with rate

With absorber → Showers yield potentially much larger charge.

But annoying effect shows up...



Operation in showers (1)

Under high deposited charge, we observed a pedestal shift

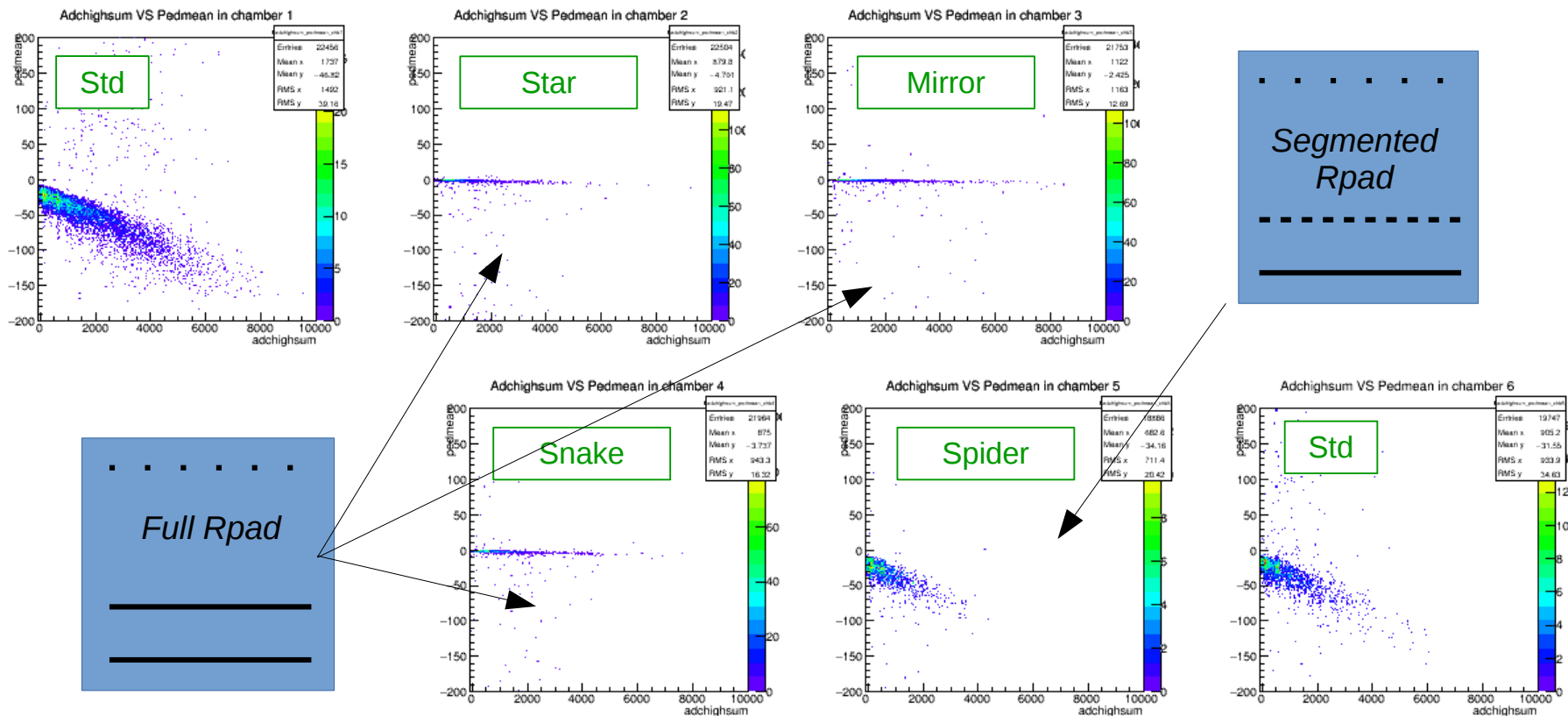
The shift seems to be proportional to the deposited charge

It shows up strongly in the non-R prototypes and 1 R with segmented R-pad

→ Implies corrections when measuring the energy

We think we see the small negative coupling between pads through the mesh

→ This coupling is strongly suppressed with full R-pads but not with segmented R-pads

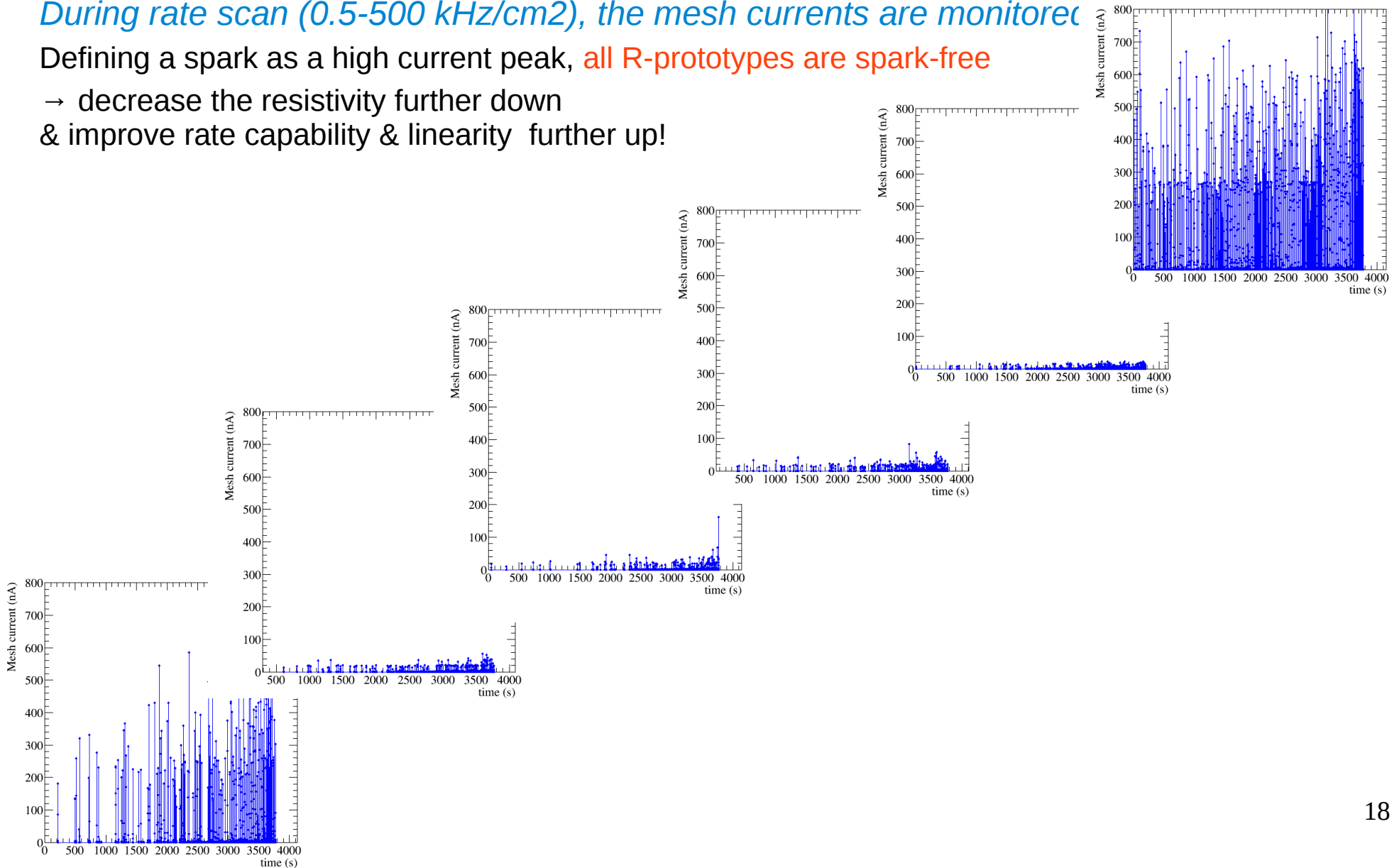


Operation in showers (2)

During rate scan (0.5-500 kHz/cm²), the mesh currents are monitored

Defining a spark as a high current peak, **all R-prototypes are spark-free**

→ decrease the resistivity further down
& improve rate capability & linearity further up!



Conclusions

- A Micromegas calorimeter should incorporate resistive elements to guarantee stability. For most applications, it seems that this can be done without spoiling the intrinsic linearity & high rate capability of the detector. More work is needed to quantify this:
 - Models & protocols
 - New prototypes with lower R
 - Test-beam (with electrons?)
- This talk mostly focused on resistive technology. Sorry for that as mechanical designs & production aspects are as important.